



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: A8700

Lawrence SHAH, et al.

Appln. No.: 10/813,269

Confirmation No.: 5356

Group Art Unit: 2828

Filed: March 31, 2004

Examiner: Dung T. NGUYEN

For: FEMTOSECOND LASER PROCESSING SYSTEM WITH PROCESS PARAMETERS
CONTROLS AND FEEDBACK

AMENDMENT UNDER 37 C.F.R. § 1.114(c)

MAIL STOP RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 5, 2007, please amend the above-identified application as follows on the accompanying pages.

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